

Docket No.: 060188-0719

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Hidetoshi YOSHIDA
Application No.: 10/718,607

: Customer Number: 20277
: Confirmation Number: 1705
: Group Art Unit: 2822
: Examiner: TRINH, Michael Manh

Filed: November 24, 2003
For: CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of May 27, 2005 wherein restriction has been required, Applicant hereby elects Group I (claims Claims 1-7) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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Registration No. 36,139
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as our correspondence address.**

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Date: June 24, 2005

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